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In re application of:

McQuade, Francis T.

Docket:

102276-200

Serial No.:

10/027,146

Art Unit:

Filed:

1741

Assignee:

December 20, 2001

Barto, Charles L.

Examiner:

Wenthworth Laboratories, Inc.

Title:

Wenthworth Laboratories, Inc. Conf. No.: 3054

Method for chemically etching photo-defined micro electrical contacts

Certificate of Mailing

Date of Deposit:
I hereby certify under 37 CFR 1.8(a) that this correspondence (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to Commissioner for Patents, Washington, DC 20231.

Signed:

Total Conf. No.: 3054

Name:

INFORMATION DISCLOSURE STATEMENT TRANSMITTAL

Commissioner for Patents Washington, DC 20231

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Dear Sir:

OFFICE OF PETITIONS

Applicant wishes to make of record the items on attached Form PTO-1449.

The undersigned represents that the closest art of which he is presently aware has been cited herein and understands that this statement shall not be construed as representation that no better art exists or that a thorough patentability search has been made.

Respectfully submitted,

WIGGIN & DANA

Date:

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